



Hirofumi Uchida

Senior Vice President of SCREEN Semiconductor Solutions Co., Ltd.

Short Bio: Received MS in Chemistry from Okayama-University in 1981, and worked for Panasonic as a process engineer and then became a manager / director of Process Technology Center and Manufacturing Technology Center. Has long carrier in not only process technology development of advanced S-LSI, DRAM, Analog-LSI, CMOS sensor etc., but also new fab start-up experience.

Moved to DAINIPPON SCREEN MFG.CO., LTD. in 2012, as a Vice President in charge of Technology Development of Semiconductor Equipment, responsible for tool and process development including wet cleaning, scrubber, flash lamp anneal and direct imagers system.

Since 2017, responsible for Global Quality Operations and Alliance as a Senior VP of SCREEN Semiconductor Solutions Co.,Ltd and a member of ISSM Japan Organizing Committee.